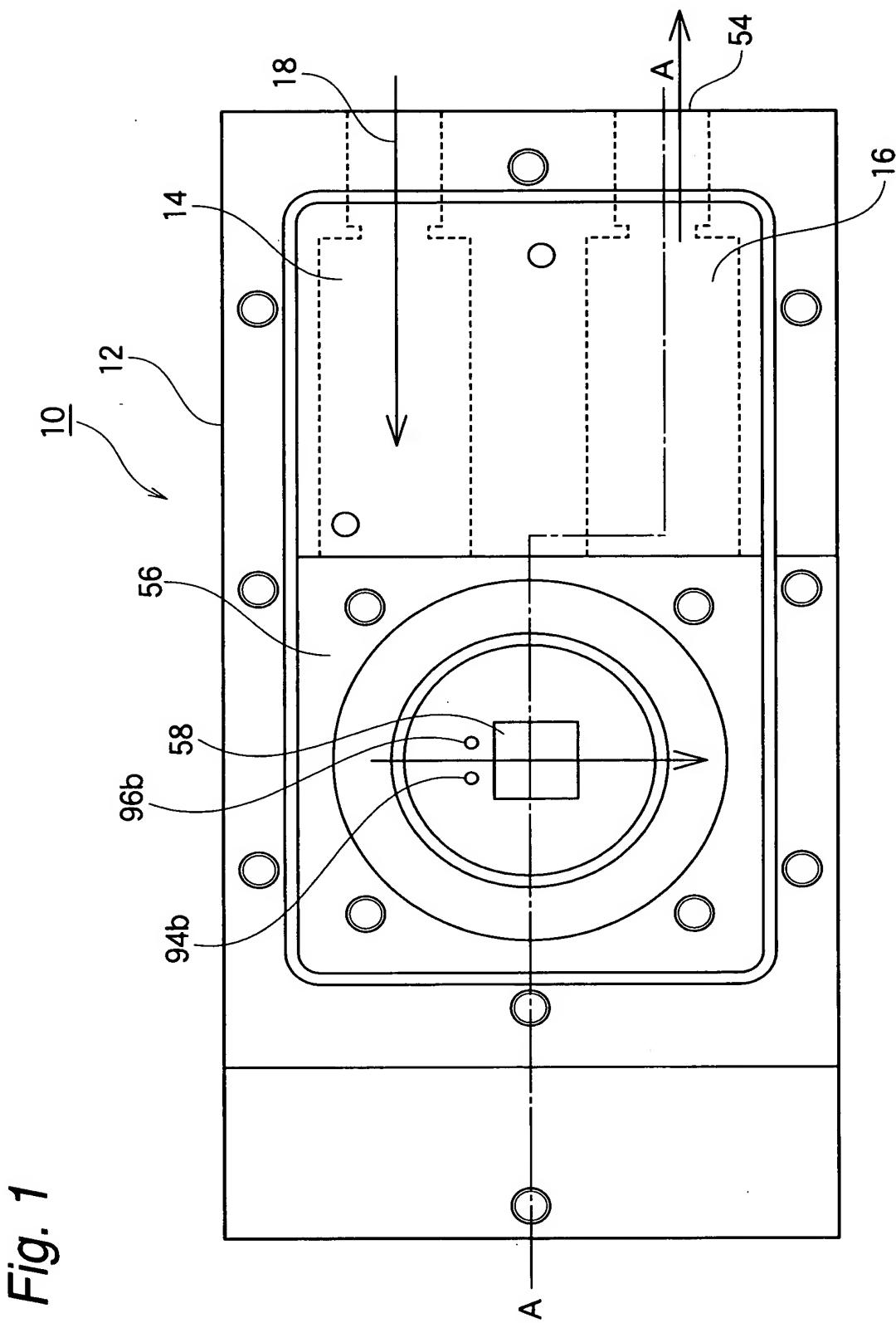
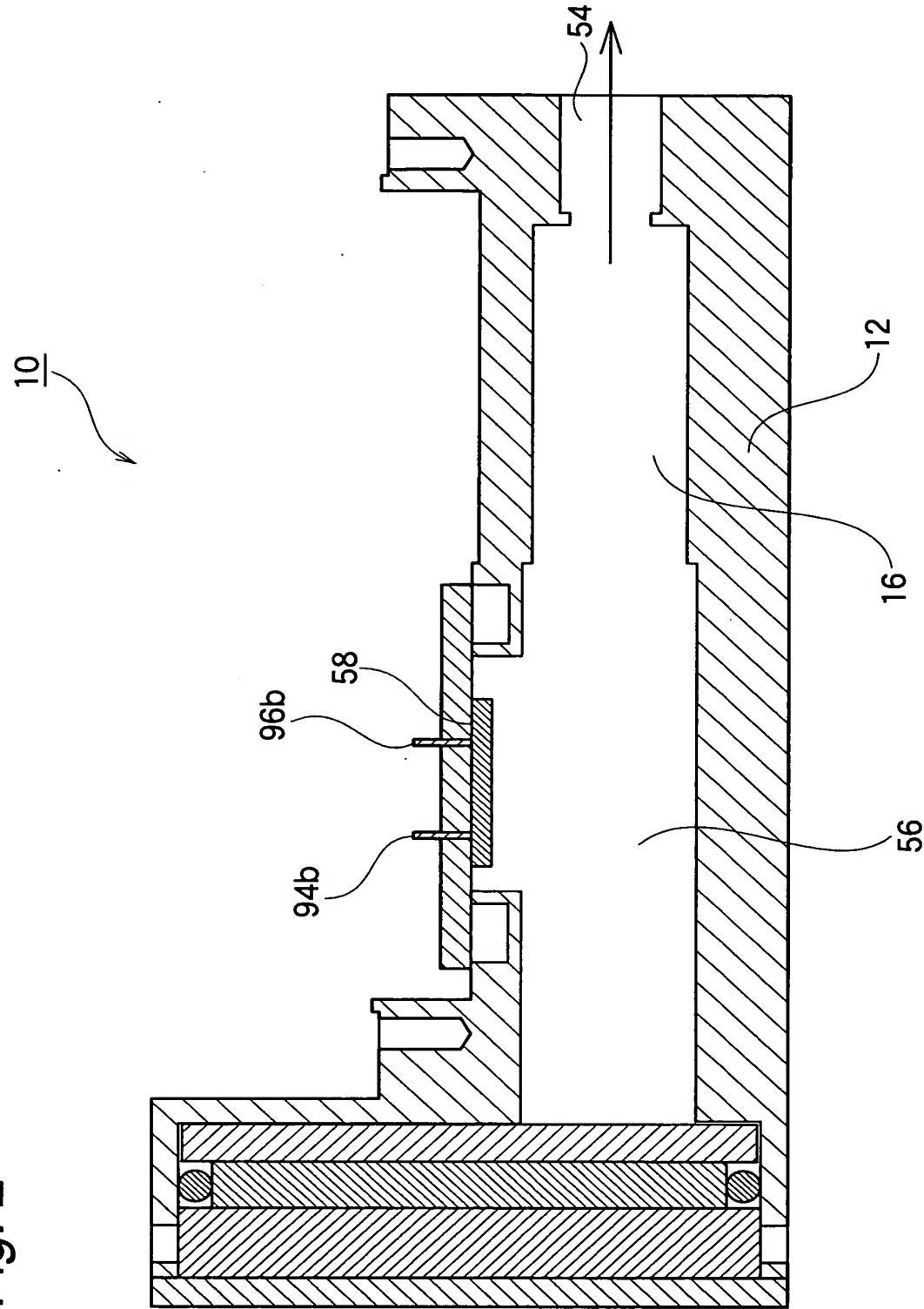


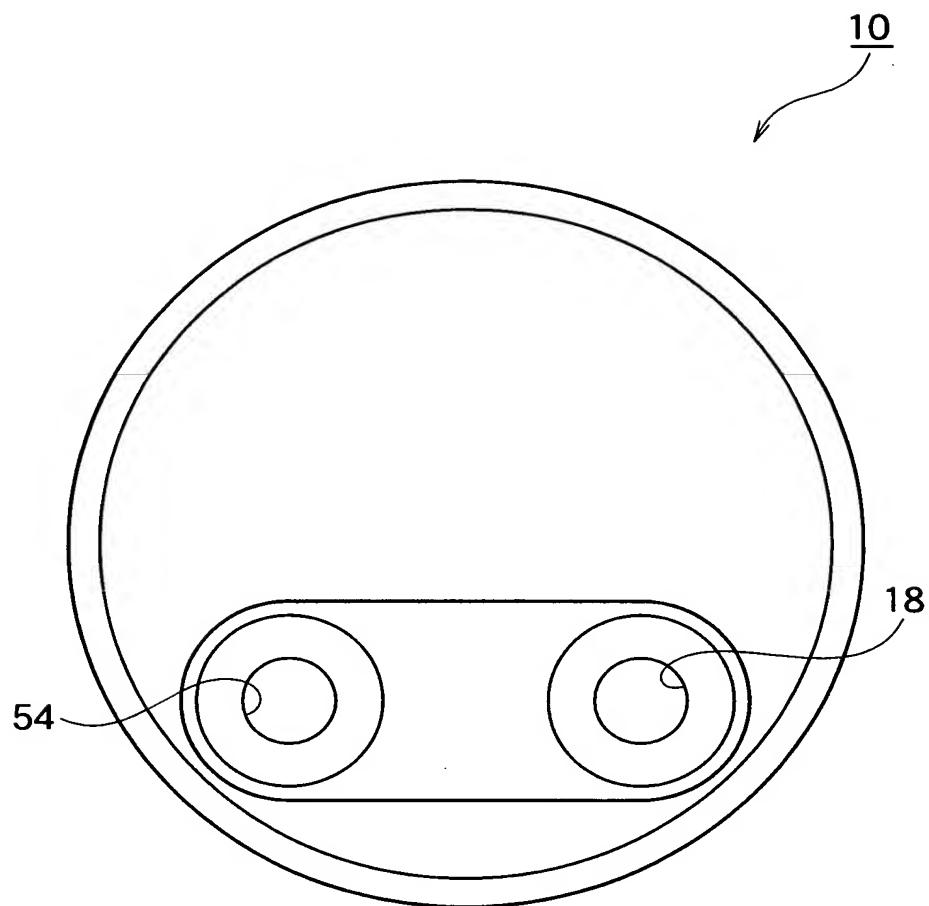
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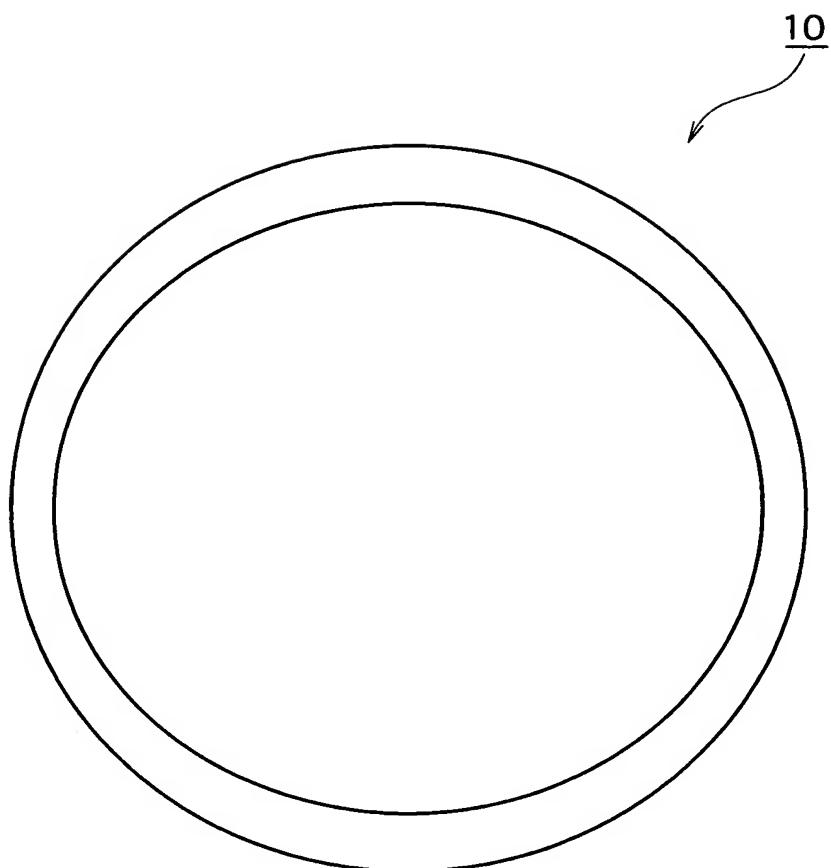
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*Fig. 3*

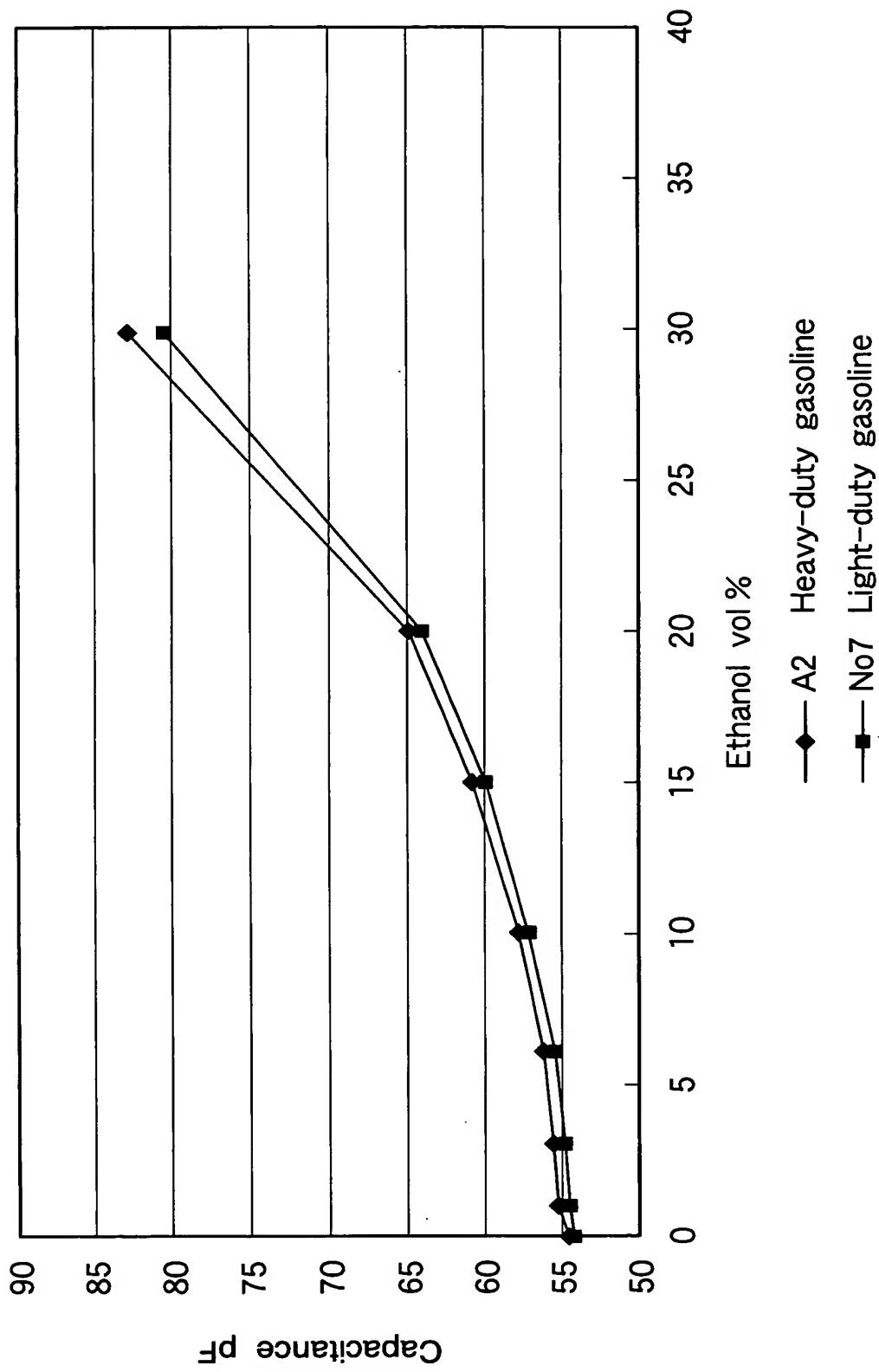


*Fig. 4*

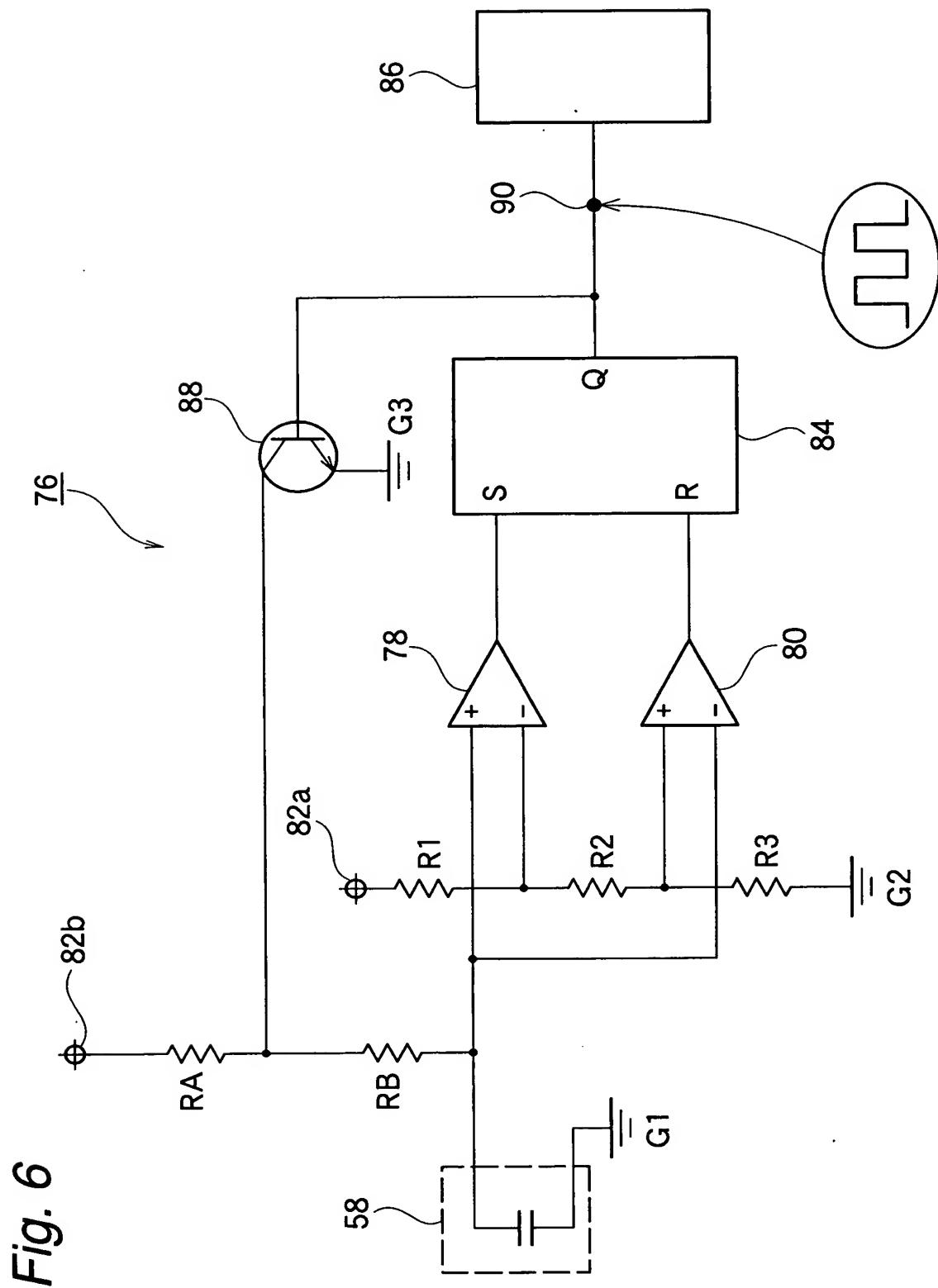


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Fig. 5



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Fig. 7

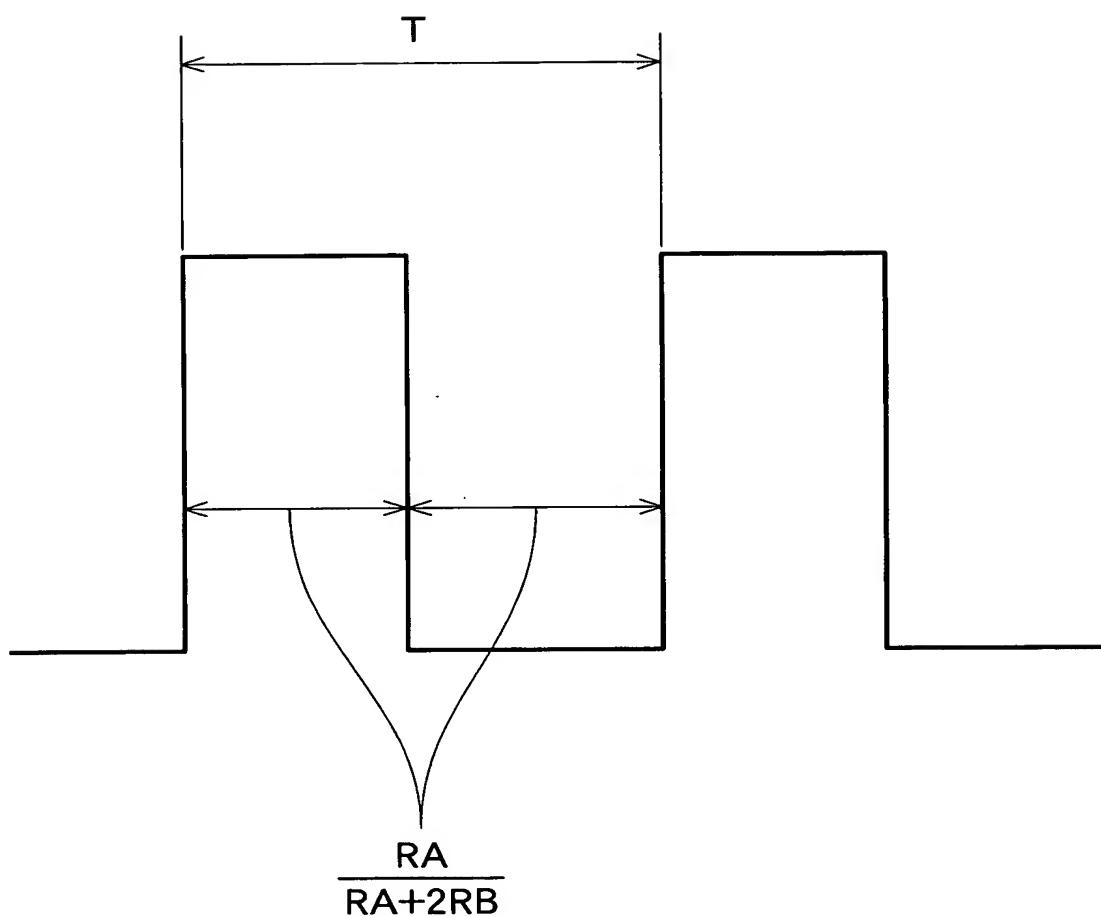
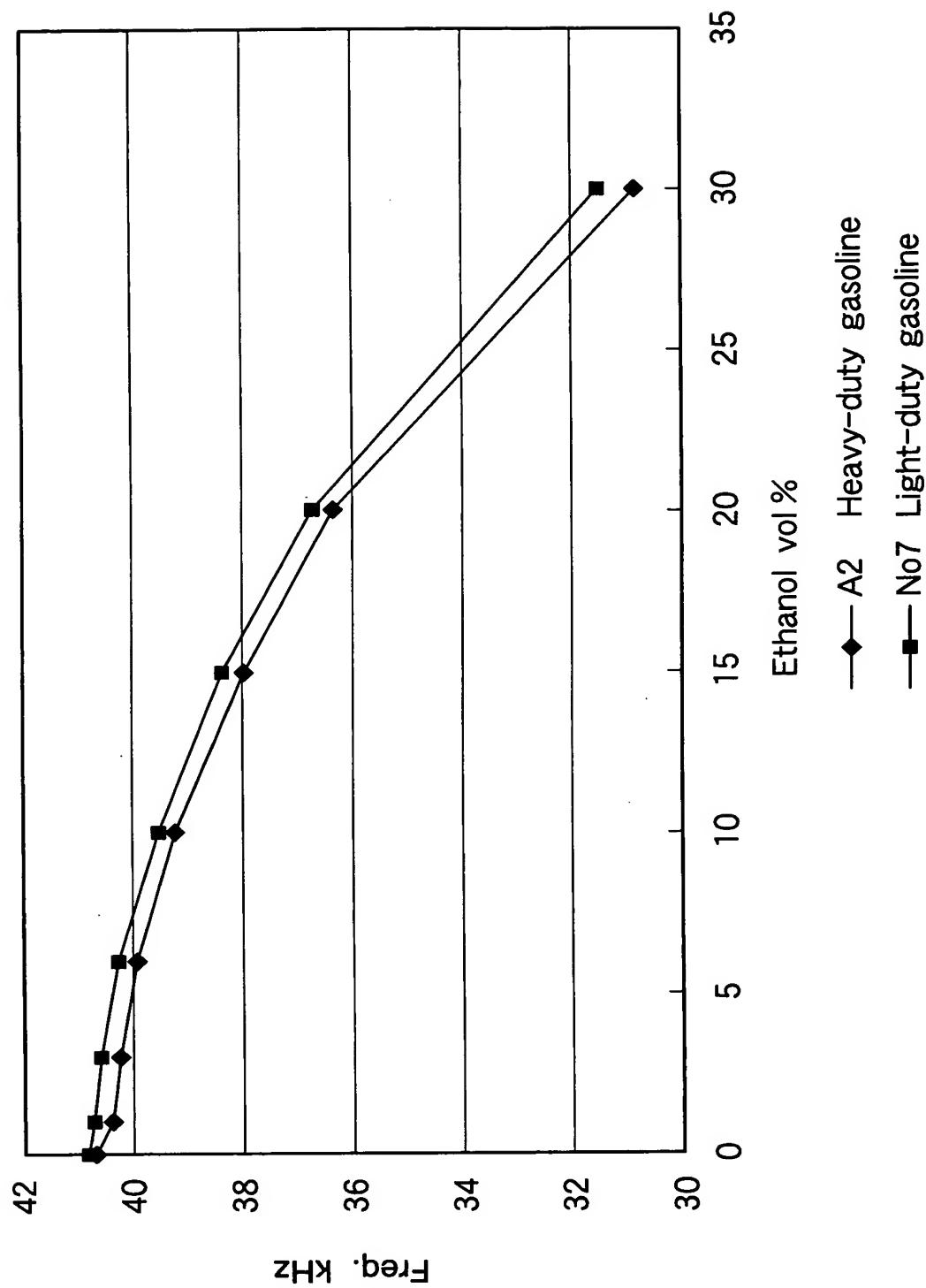


Fig. 8



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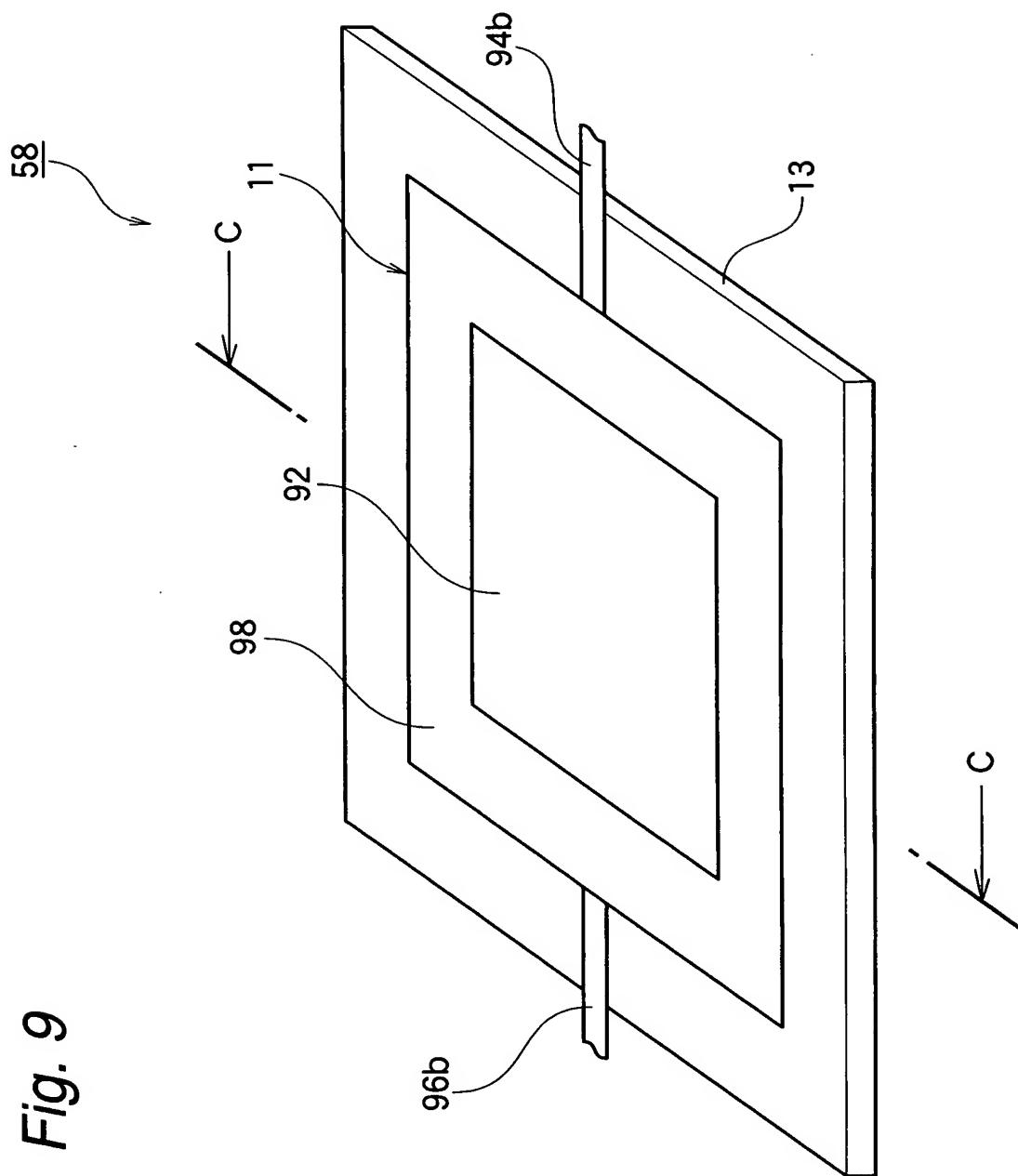
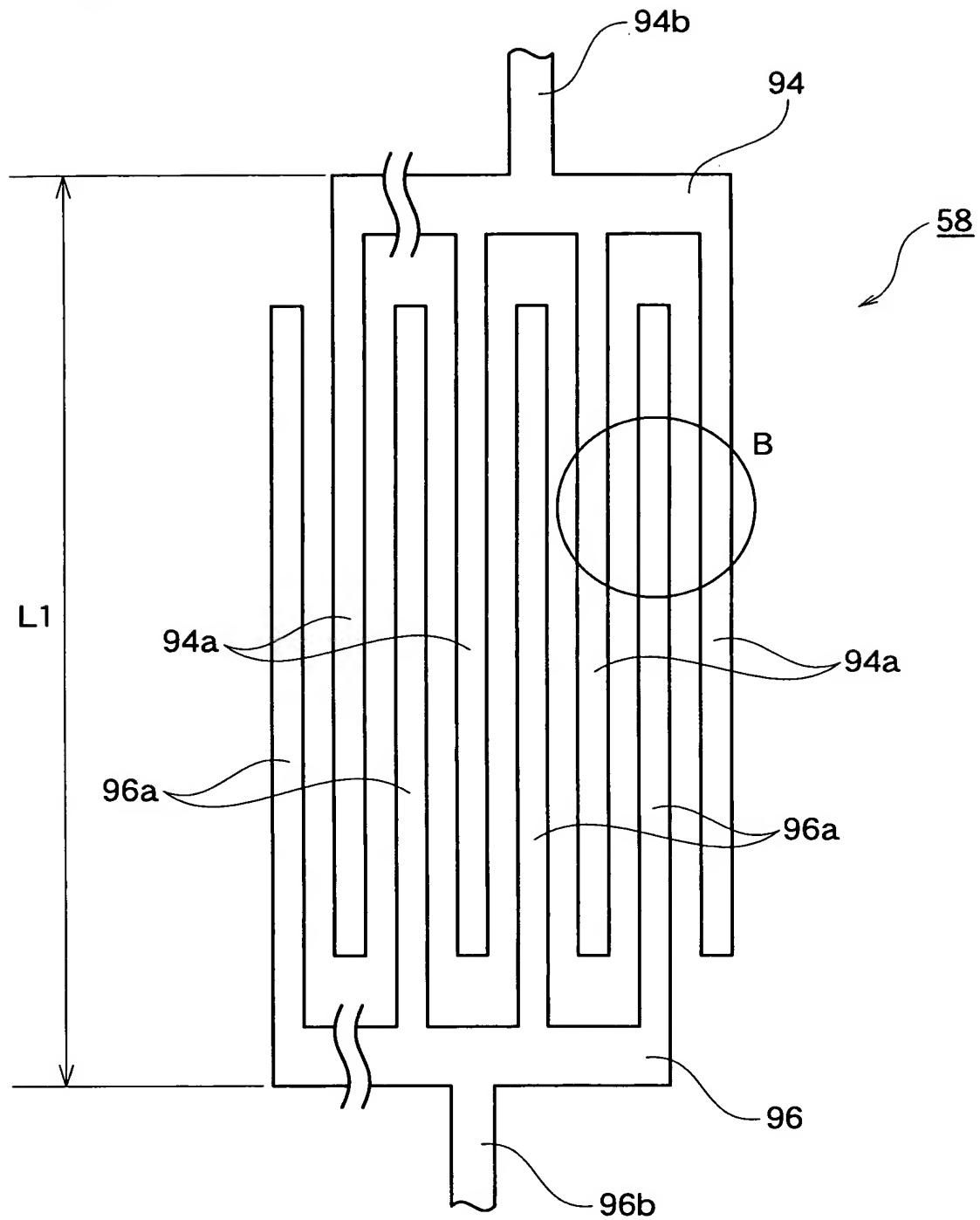


Fig. 9

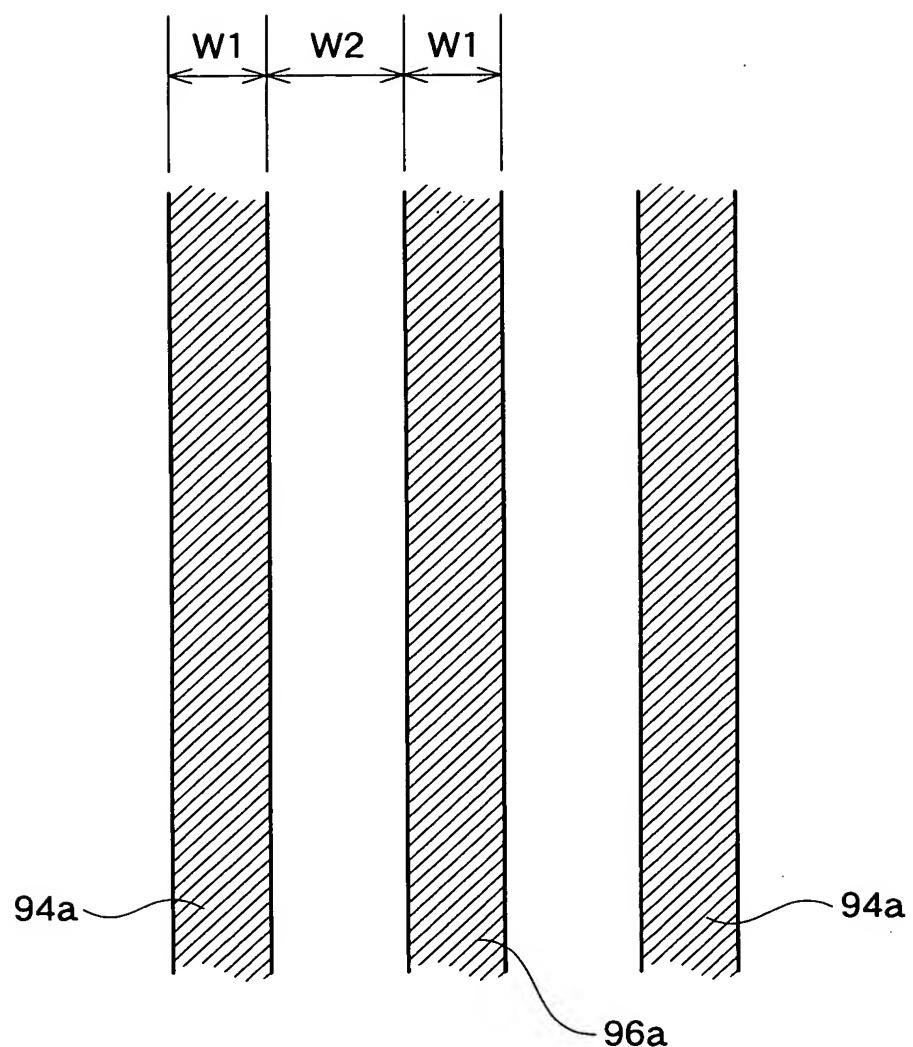
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Fig. 10

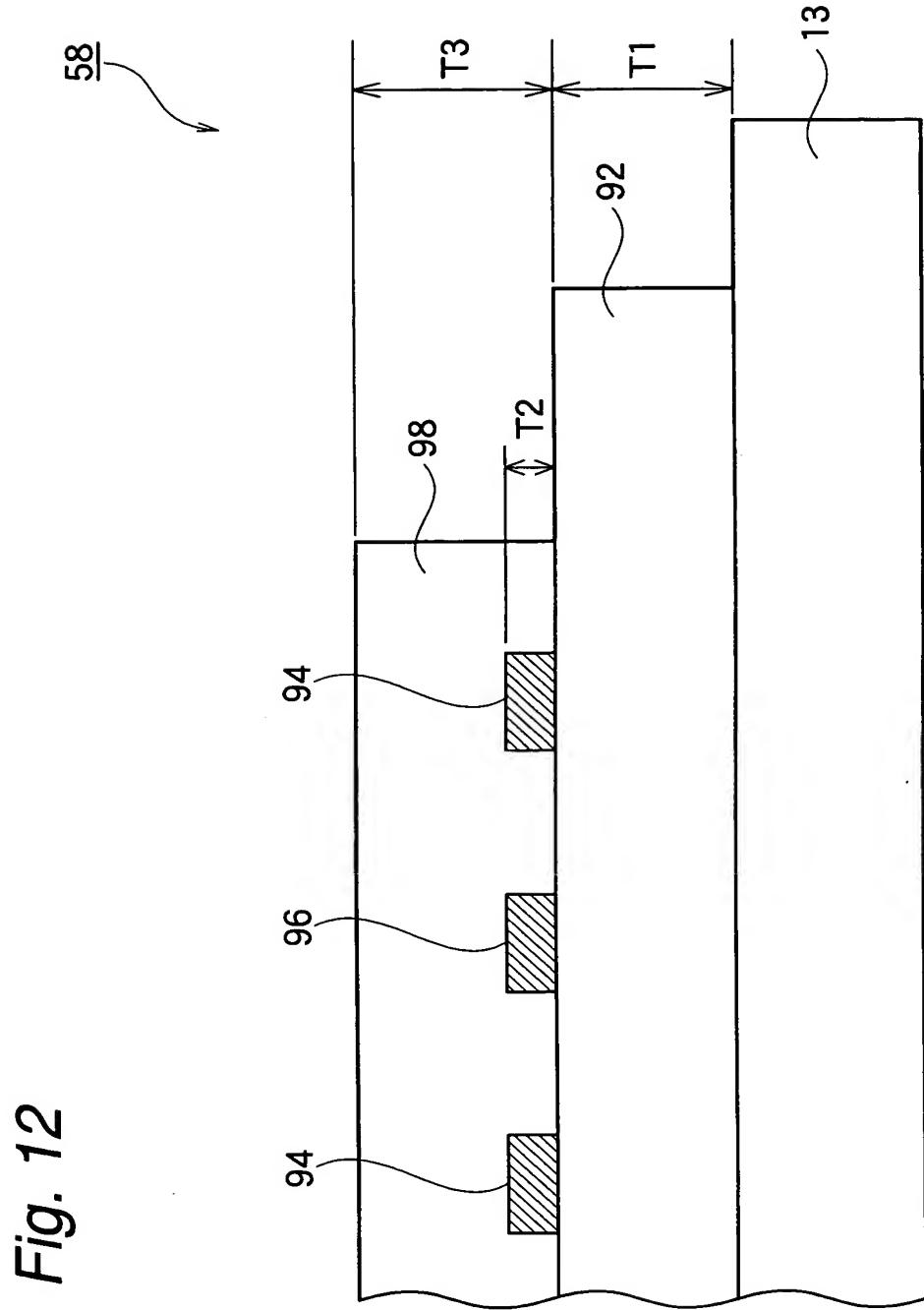


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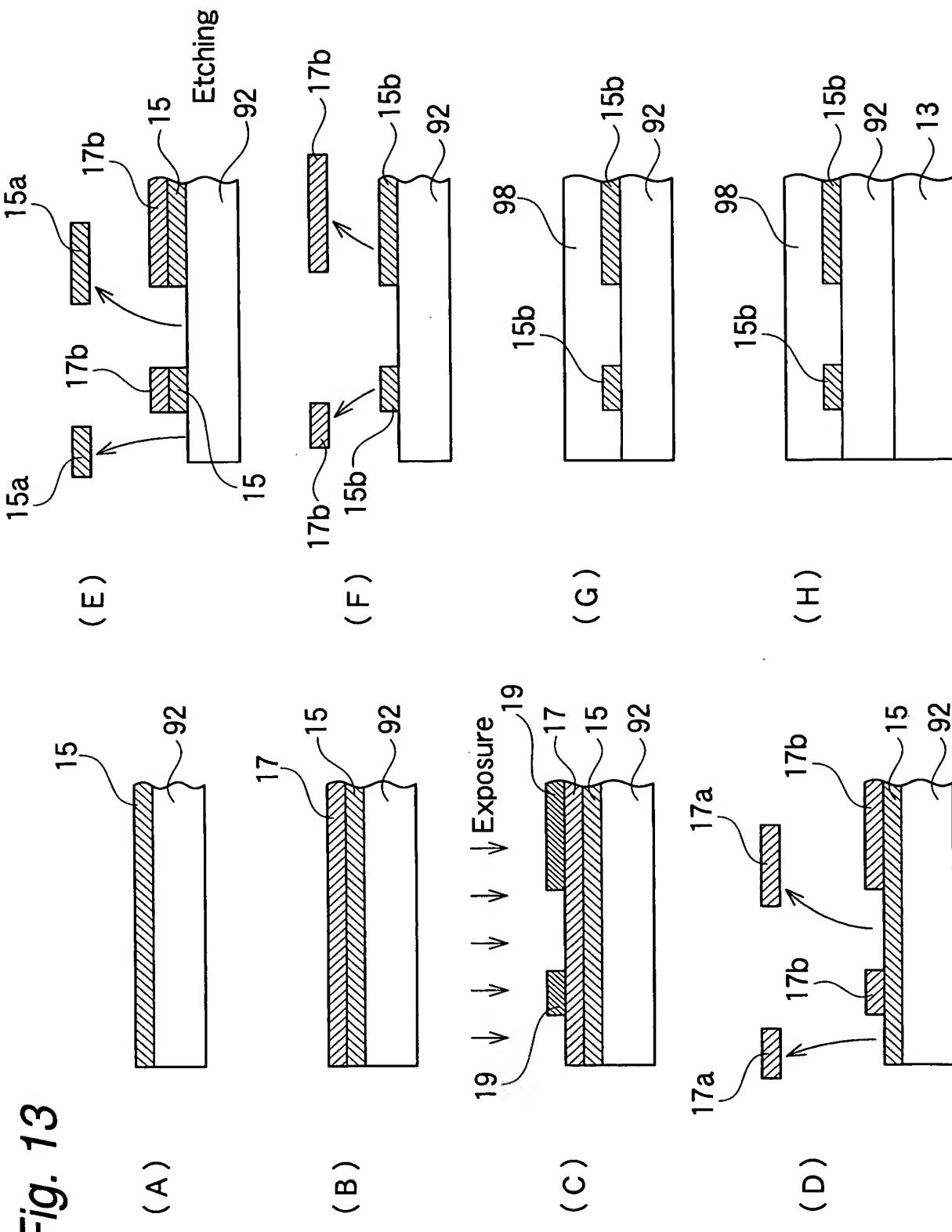
Fig. 11



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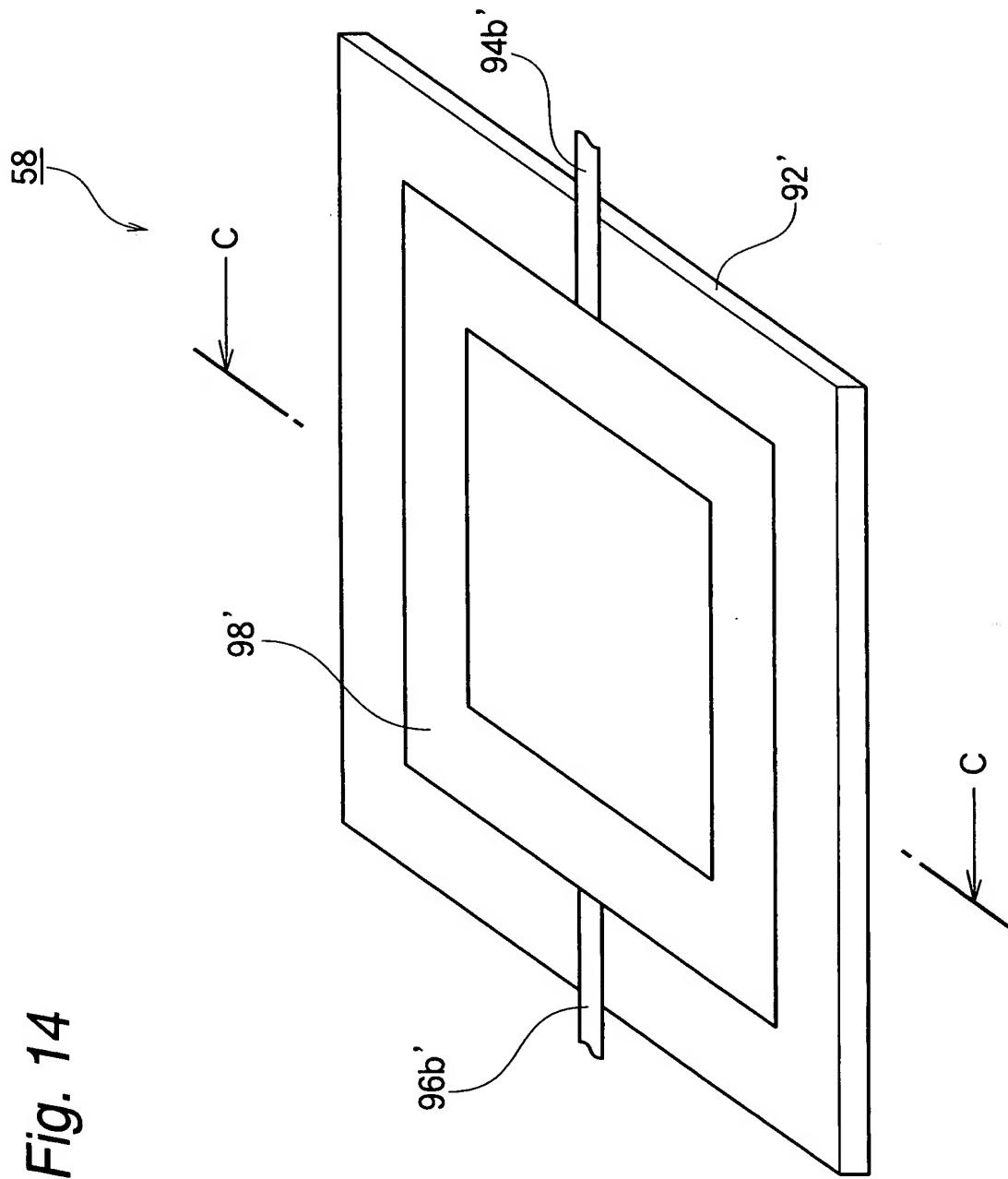
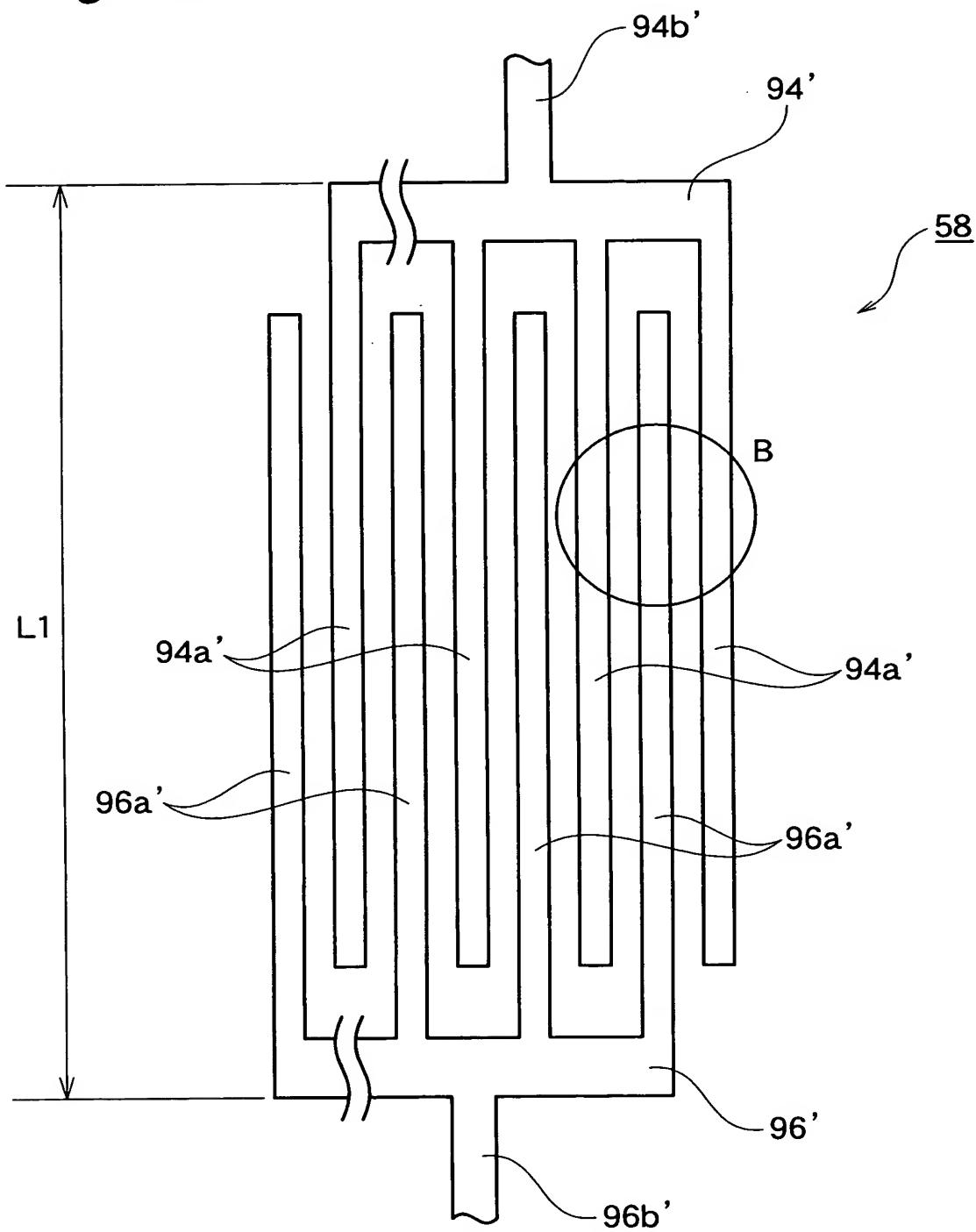


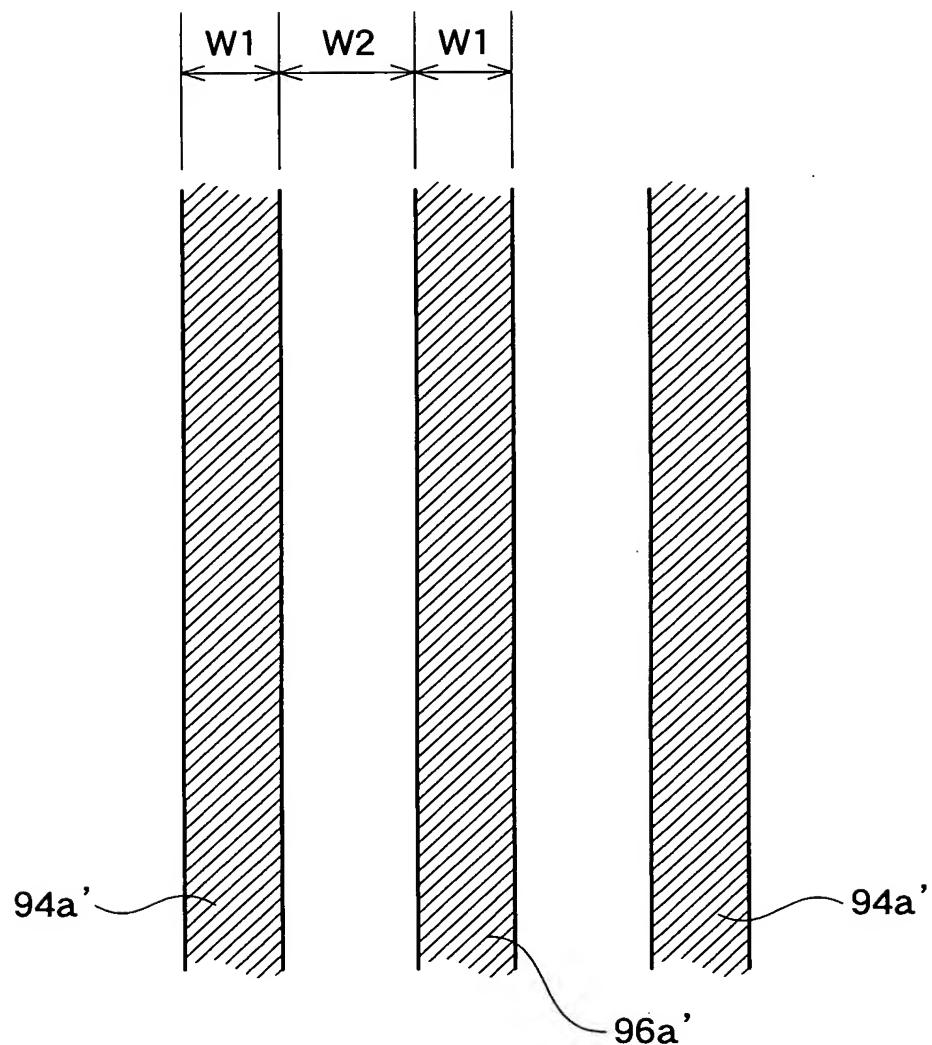
Fig. 14

Fig. 15



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Fig. 16



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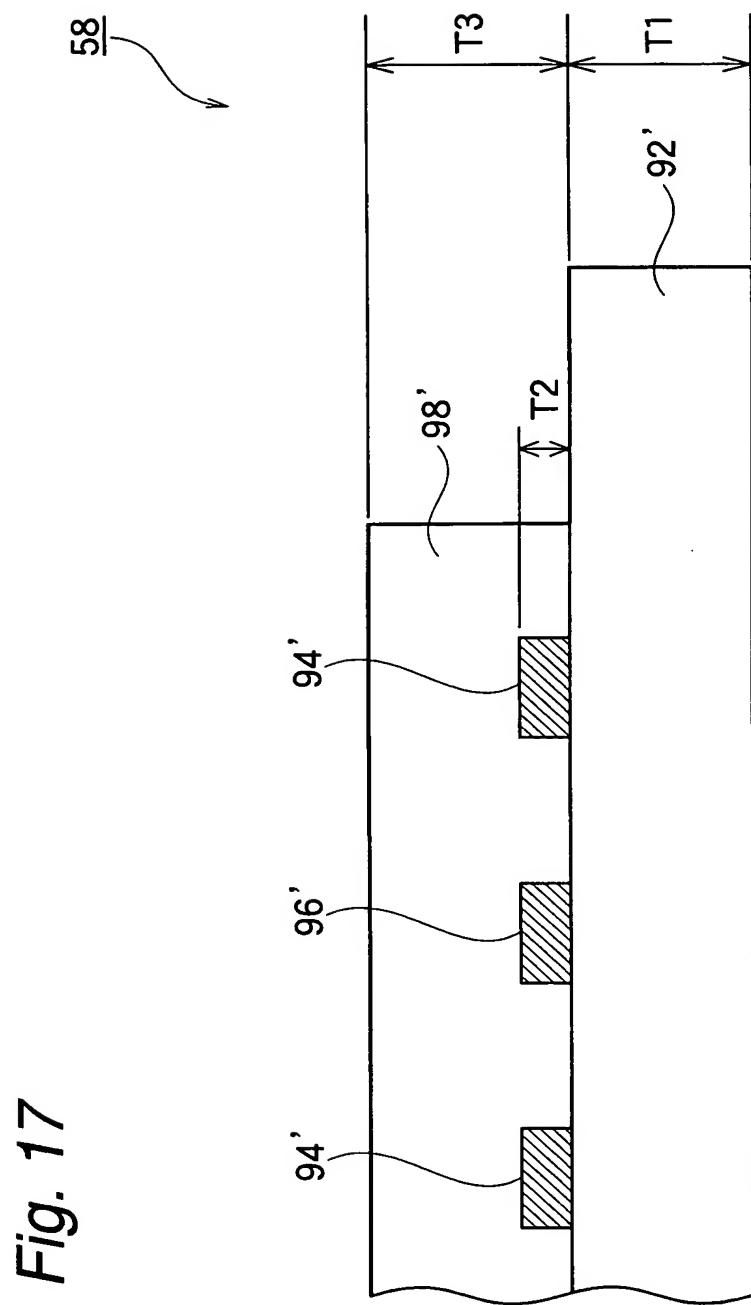
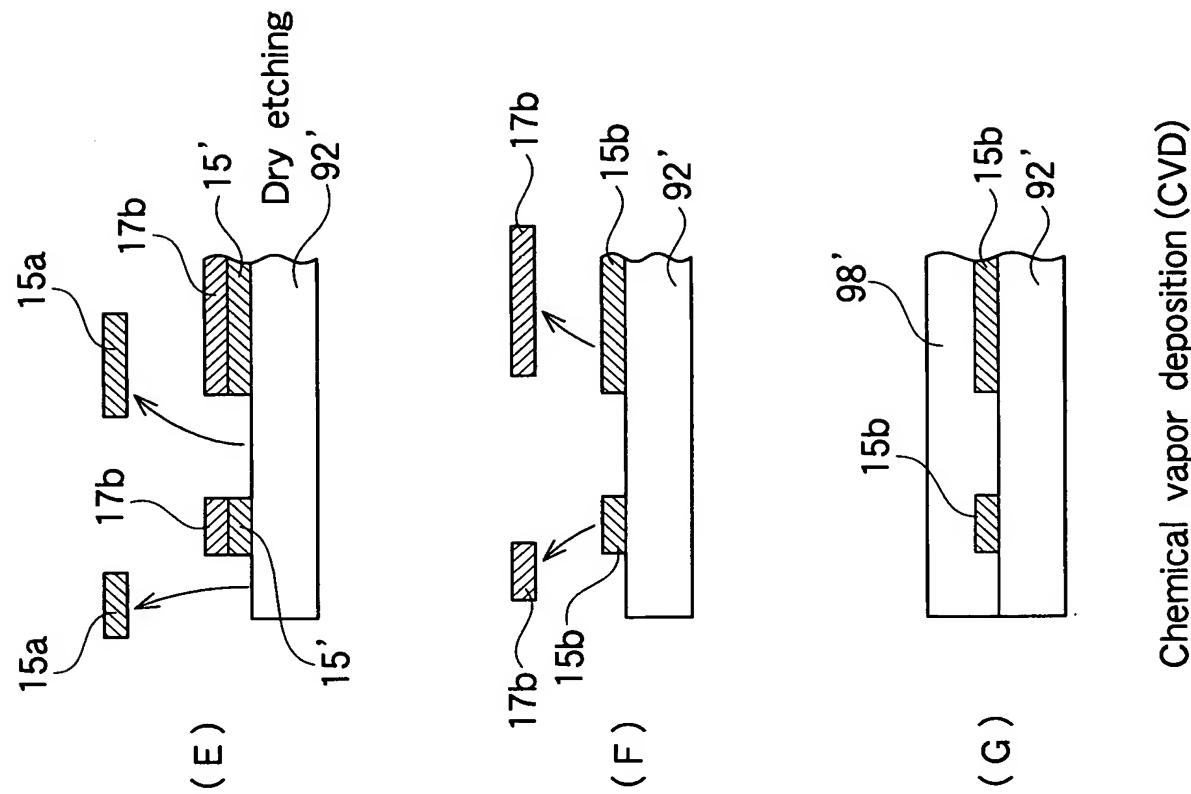
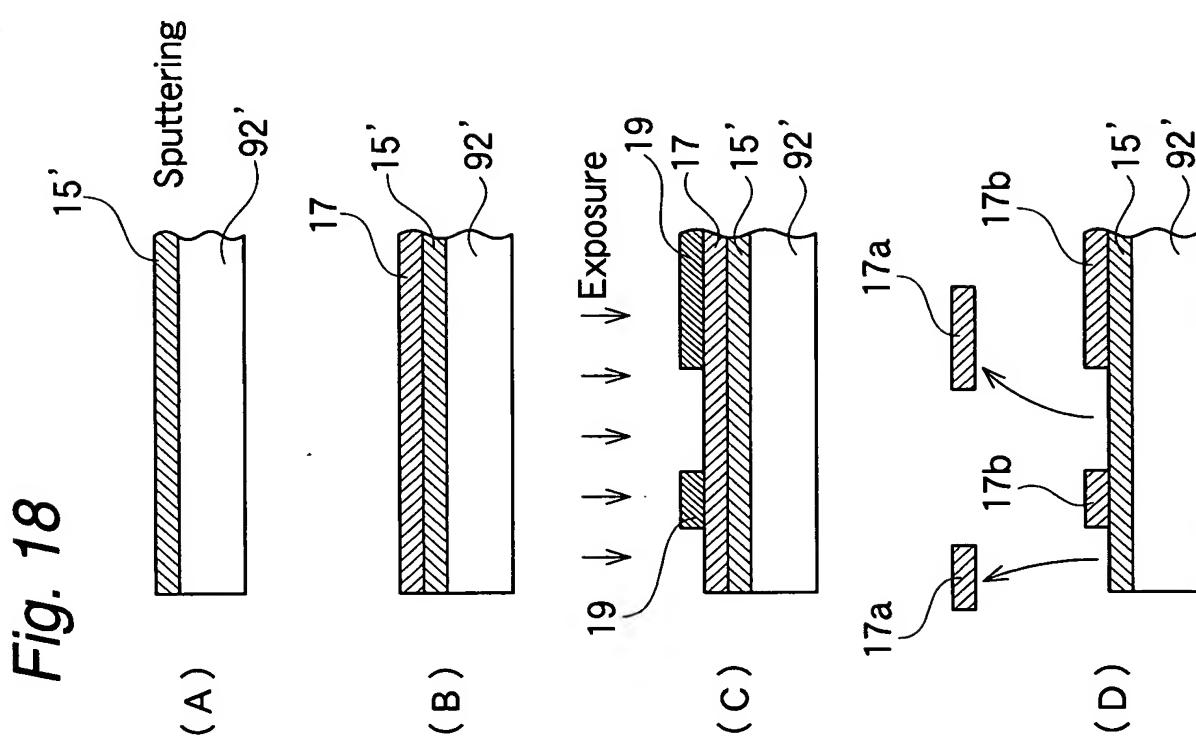


Fig. 17

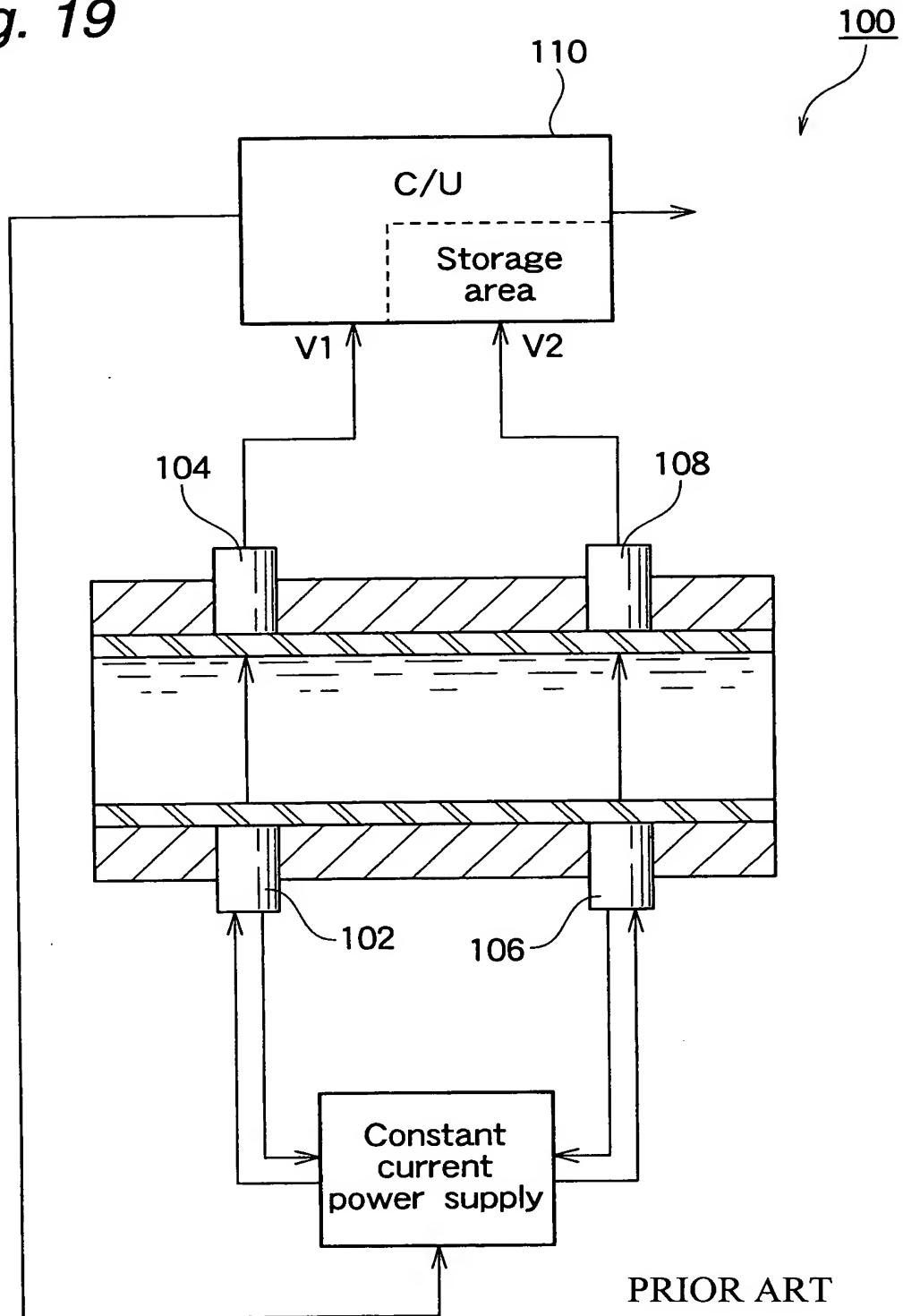
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Chemical vapor deposition (CVD)

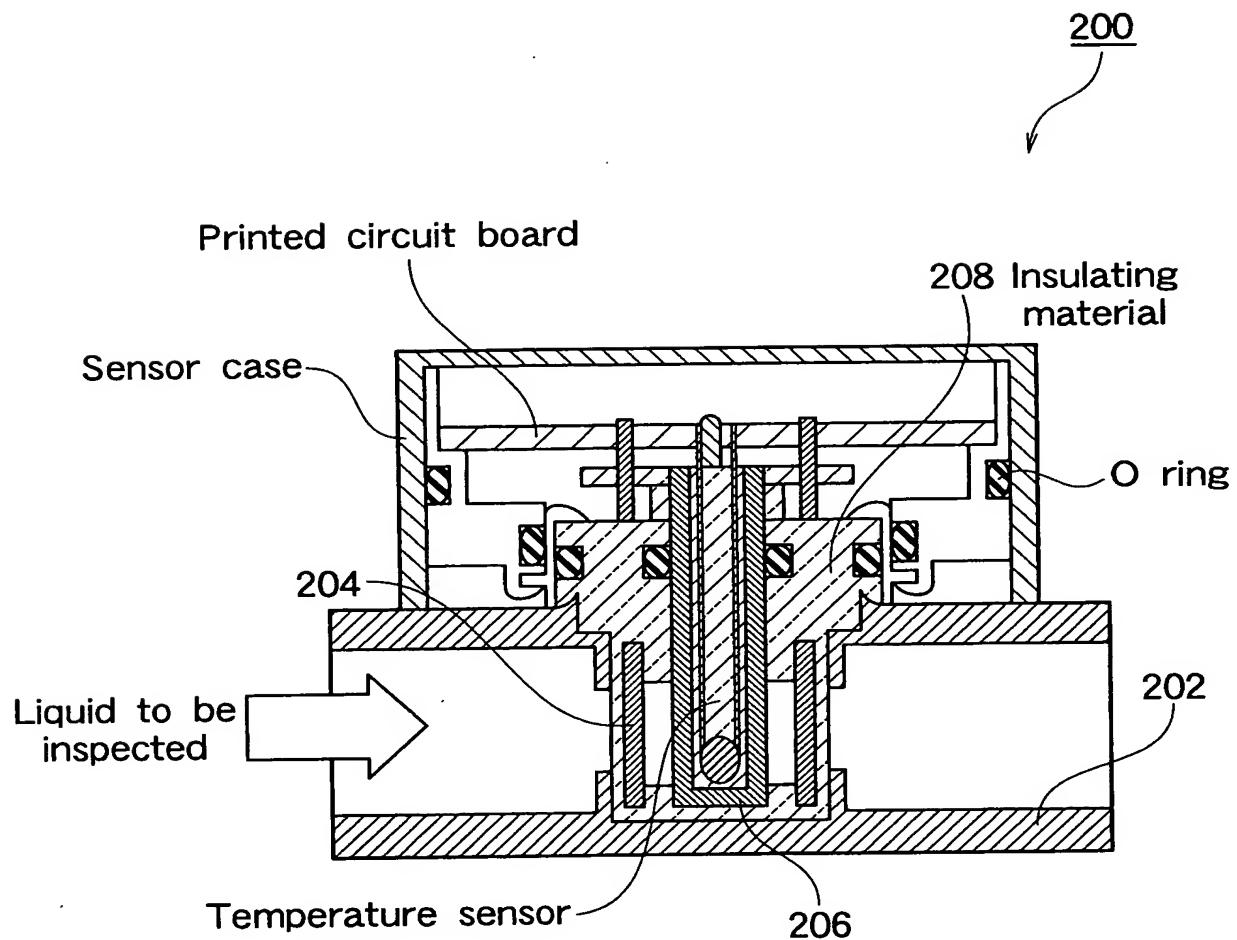
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Fig. 19



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Fig. 20



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